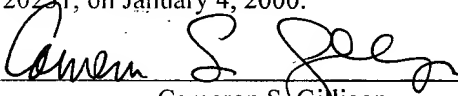


Docket: 0756-1961

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on January 4, 2000.

  
Cameron S. Gilligan

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

8/a  
FJONES  
2-2-00

In re PATENT application of

Shunpei YAMAZAKI et al.

Serial No. 09/295,607

Filed: April 22, 1999

For: SEMICONDUCTOR DEVICE AND

METHOD FOR FORMING THE

SAME

) **BEST AVAILABLE COPY**

) Group Art Unit: 2811

) Examiner: S. Loke

) Date: January 4, 2000

**AMENDMENT**

Assistant Commissioner for Patents  
Washington, D.C. 20231

**RECEIVED**  
JAN 11 2000  
TECHNOLOGY CENTER 2800

Sir:

In response to the Office Action of August 4, 1999, please amend the above-identified application as follows.

**IN THE TITLE:**

Please replace the current title with the following:

--SEMICONDUCTOR DEVICE HAVING ALUMINUM NITRIDE FILM--

01/10/2000 HSHIFERA 00000103 09295607

85 FC:102

108.00 DP  
234.00 DP

01/10/2000 HSHIFERA 00000103 09295607  
108.00 DP  
234.00 DP  
02 FC:103  
03 FC:102